

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10784903
	Filing Date		2004-02-20
	First Named Inventor	Issaq et al.	
	Art Unit	2811	
	Examiner Name	Nadav, Ori	
	Attorney Docket Number	ACT-390	

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	2	5008855	A	1991-04-16	Eltoukhy et al.	
	3	5126282	A	1992-06-30	Chiang et al.	
	4	5807786	A	1998-02-15	Chang	
	5	5965270	A	1999-10-12	Fang et al.	
	6	6107165	A	2000-08-22	Jain et al.	
	7	6124193	A	2000-09-26	Hawley et al.	
	8	6130572	A	2000-10-10	Ghilardelli et al.	

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9	6259130	B1	2001-07-10	Wu	
10	6316346	B1	2001-11-13	Gangopadhyay	
11	6529038	B2	2003-03-04	Lambertson	
12	6728126	B1	2004-04-27	Issaq et al.	
13	6767769	B2	2004-07-27	Hawley et al.	
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	2	20030205723	A1	2003-11-06	Hawley et al.	

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	1	2003030217	WO	A2	2003-04-10	Actel Corporation		<input type="checkbox"/>
	2	2003030217	WO	A3	2003-04-10	Actel Corporation		<input type="checkbox"/>
	3	2005081976	WO	A3	2005-09-09	Actel Corporatoin		<input type="checkbox"/>
	4	1305454	GB	A	1973-01-31	Schunk & Ebe GMBH		<input type="checkbox"/>
	5	1461824	EP	A2	2004-09-29	Actel Corporation		<input type="checkbox"/>
	6	1721338	EP	A2	2006-11-15	Actel Corporation		<input type="checkbox"/>

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	1	Co-pending United States Patent Application No. 11/078,952 filed March 10, 2005 entitled SWITCHING RATIO AND ON-STATE RESISTANCE OF AN ANTIFUSE PROGRAMMED BELOW 5 mA AND HAVING A Ta or TaN BARRIER METAL LAYER.	<input type="checkbox"/>
	2	Co-pending United States Patent Application No. 10/625,490 filed July 22, 2003 entitled IMPROVING THE SWITCHING RATIO AND ON-STATE RESISTANCE OF AN ANTIFUSE PROGRAMMED BELOW 5 mA AND HAVING A Ta or TaN BARRIER METAL LAYER.	<input type="checkbox"/>

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3	Co-pending United States Patent Application No. 11/195,002 filed August 1, 2005 entitled REPROGRAMMABLE METAL-TO-METAL ANTIFUSE EMPLOYING CARBON-CONTAINING ANTIFUSE MATERIAL.	<input type="checkbox"/>
4	Co-pending United States Patent Application No. 11/210,492 filed August 23, 2005 entitled AMORPHOUS CARBON METAL-TO-METAL ANTIFUSE WITH ADHESION PROMOTING LAYERS.	<input type="checkbox"/>
5	European Supplementary Search Report issued December 4, 2006 in European Patent Application No. 02776069.3, based on International Patent Application No. PCT/US02/31253 of co-pending United States Patent Application No. 09/972,825.	<input type="checkbox"/>

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